

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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**Patent No.:** 6,878,593

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**Applicant:** Khan et al.

**Docket No.:** SETI-0002-DIV

**Title:** METAL OXIDE SEMICONDUCTOR HETEROSTRUCTURE FIELD EFFECT  
TRANSISTOR

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Notification of Change in Small Entity Status**

Sir:

The assignee of the above-referenced patent is no longer entitled to Small Entity Status for the above-referenced patent. Should the Office require anything further to change the entity status, the Office is invited to contact the assignee's undersigned representative at the number listed below.

Respectfully submitted,

/John LaBatt/

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